



PATENT  
Attorney Docket No. 0553-0299

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: )  
)  
Takashi Hamada et al. )  
)  
Serial No: 10/051,064 )  
)  
Filed: January 18, 2002 )  
)  
Art Unit: 2823 )  
)  
Examiner: F. Toledo )  
)  
For: SEMICONDUCTOR DEVICE )  
AND METHOD OF )  
MANUFACTURING THE SAME )

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on

September 16, 2003

Signature

*[Handwritten Signature]*

Date September 16, 2003

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT A

Dear Sir:

In response to the Office Action dated May 20, 2003, please amend the above-identified application as follows.

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